



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

October 2, 2026

IGI Report Number **LG841654604**

Description **LABORATORY GROWN DIAMOND**Shape and Cutting Style **CUSHION MODIFIED BRILLIANT**

Measurements 8.76 X 6.23 X 3.93 MM

GRADING RESULTS

Carat Weight 1.79 CARAT

Color Grade D

Clarity Grade **VVS 1**

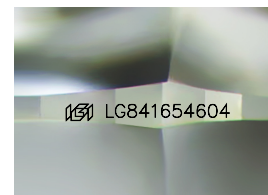
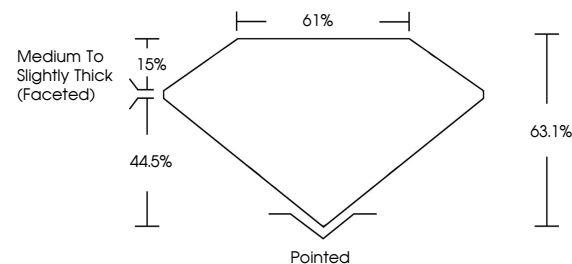
ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**Symmetry **EXCELLENT**Fluorescence **NONE**Inscription(s)  LG841654604

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG841654604
Report verification at igi.org

PROPORTIONS



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

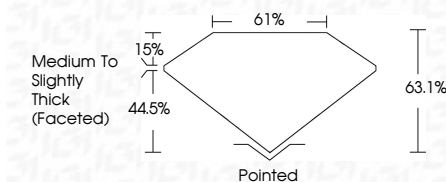
CLARITY

FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

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GRADING RESULTS	
Carat Weight	1.79 CARAT
Color Grade	D
Clarity Grade	VVS 1



ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	 LG84165460A
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa	



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www.igi.org

October 2, 2026	Color Grade	1.79 CARAT
GI Report No. LG8401654004	Clarity Grade	VVS 1
CUSHION MODIFIED BRILLIANT	Depth	63.1%
2.76 X 4.23 X 3.93 MM	Table	61%
	Grain	Medium to Slightly Thick (Faceted)
	Quiet	Pointed
	Poish	EXCELLENT
	Symmetry	EXCELLENT
	Fluorescence	NONE
	Inscriptions(s)	681 LG8401654004

Comments:
 The Laboratory Grown Diamond was
 created by Chemical Vapor Deposition
 growth process.
 type IIa